IN	THE	UNITED	STATES	PATENT	AND	TRAD	EMARK	OFFICE

APPLICANT:	Sadeg M. Faris)
) Group Art Unit
SERIAL NO.:	Tbd) Tbd
)
FILING DATE:	November 20, 2003) Examiner

FOR: Method Of Fabricating Multi Layer

Devices On Buried Oxide Layer Substrates

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

TRANSMITTAL of NEW PATENT APPLICATION UNDER 37 CFR 1.53

Sir:

Applicant is a small entity.

Please find enclosed herewith:

- 1) New Patent Application, including:
 - a. Specification (84 pages)
 - b. Claims (4 pages)
 - c. Abstract (1 page)
 - d. Figures (50 sheets)
- 2) Declaration and Power of Attorney (unexecuted)
- 3) Postcard

Respectfully submitted,

Bosco B Ki

Registration No. 41,896

) Tbd

Date: November 20, 2003 REVEO, INC.

85 Executive Boulevard Elmsford, New York 10523 Telephone (914) 345-9555

Facsimile: (914) 345-9558

I hereby certify that this correspondence is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 in an envelope addressed to:

Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

November 20, 2003

(Date of Deposit)

Bosco B. Kim

(Name of Person Mailing Paper)

11/20/63

Signature

Date

EV 139311559 US

("Express Mail" Mailing Label Number)

Page 1 of 1

